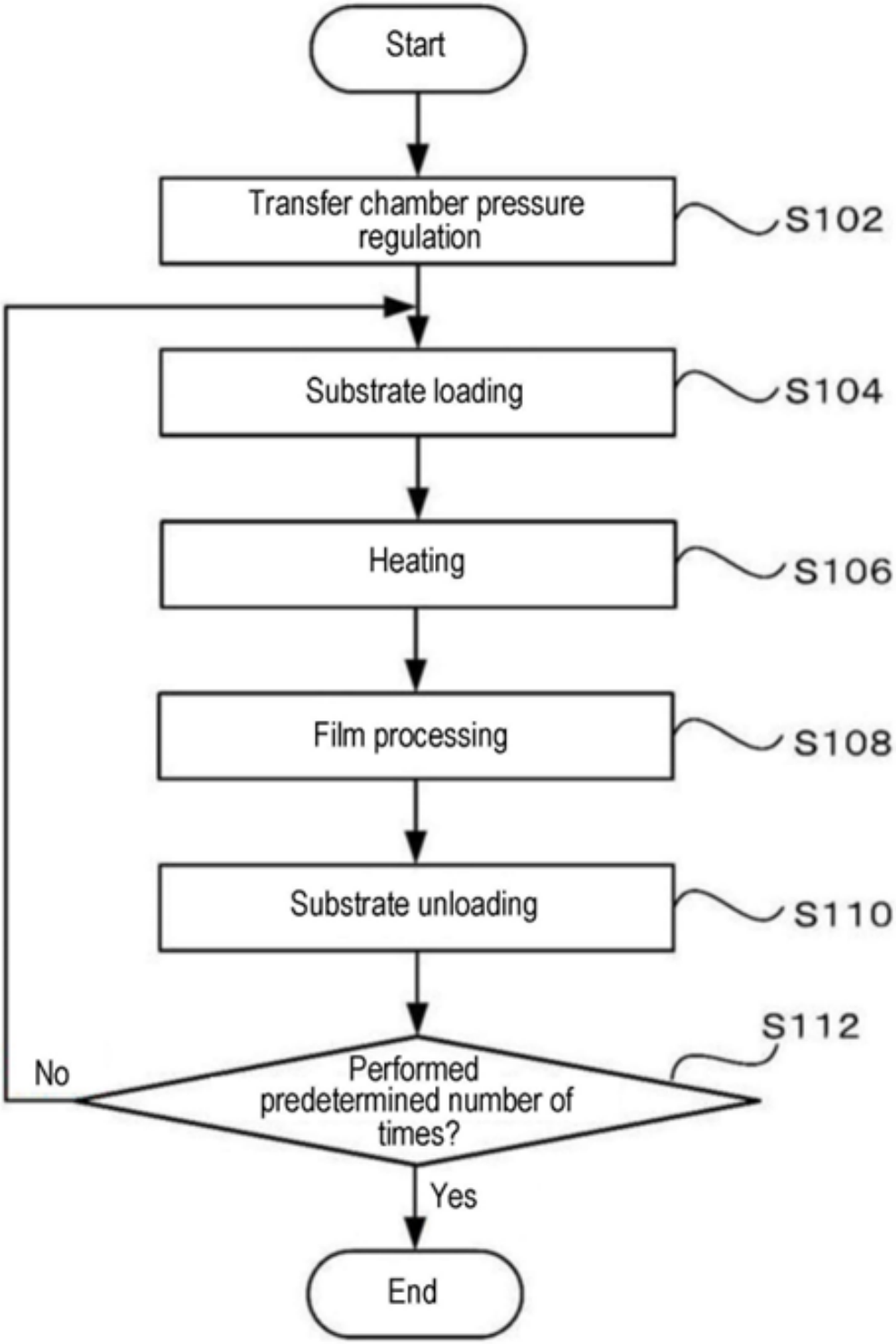
FIG. 6


Start
Transfer chamber pressure regulation
S102
Substrate loading
S104
Heating
S106
Film processing
S108
Substrate unloading
S110
S112
Performed predetermined number of times?
No
Yes
End